## SINGLE ASSIGNEE CASE SPECIFIC POWER OF ATTORNEY

## POWER OF ATTORNEY and CORRESPONDENCE ADDRESS INDICATION FORM and STATEMENT UNDER 37 CFR 3.73(b)

Application or Control Number	10/752,642	
Filing Date	January 07, 2004	
First Named Inventor	Naofumi Nakamura	
Title: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING		
THE SAME		
Attorney Docket Number:		

I hereby appoint:			
■ Practitioners associated with the Customer Number 228	50		
as my/our attorney(s) or agent(s) to prosecute the application/reexamination pall business in the United States Patent and Trademark Office connected there			
Please recognize or change the correspondence address for the above-identito:	fied application/reexamination proceeding		
The address associated with the above-mentioned Customer Number.			
I am the:  Assignee of record of the entire interest. See 37 CFR 3.71.			
Kabushiki Kaisha Toshiba , a Corporation			
	ee, e.g., corporation, partnership, ncy, etc.)		
States that it is the assignee of the entire right, title, and interest. The Ass Patent and Trademark Office at Reel, Frame, o attached.			
As required by 37 CFR 3.73(b)(1)(i), the documentary evidence of the cha assignee was, or concurrently is being, submitted for recordation pursuant	in of title from the original owner to the t to 37 CFR 3.11.		
SIGNATURE OF ASSIGNEE OF RECORD			
The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.			
Signature	<u>June 9 , 2009</u> Date		
Hiroshi MIYAUCHI	03-3457-2500		
Printed or Typed Name	Telephone Number		
General Manager of Intellectu	al Property Division		
Title			
THIS FORM CAN ONLY BE SIGNED WHERE THERE IS	ONLY A SINGLE ASSIGNEE		

NOT FOR RECORDATION

## ASSIGNMENT

In consideration of value received, I, having a mailing address at c/o Intellectual Property Division, Toshiba Corporation, 1-1, Shibaura 1-chome, Minato-ku, Tokyo 105-8001, Japan and a residence as stated below next to my name, the sole inventor (if only one name is listed below) or a joint inventor (if plural inventors are listed below) of an invention described in an application for United States patent entitled:

SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

said application having been filed on January 7, 2004 and assigned Application No. 10/752,642; sell and assign to KABUSHIKI KAISHA TOSHIBA a corporation of Japan, having a business address at 1-1 Shibaura 1-chame, Minato-ku, Tokyo, Japan

its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said application for United States patent: (check one)

× executed concurrently herewith;

executed separately herefrom;

and in and to all applications for patent and patents for said invention, in all countries of the world, including all divisions, reissues, continuations, substitutions and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, reissue, or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invension in all countries.

I hereby grant the following law firm the power to insert on this Assignment any further identification which may be necessary or desirable in order to comply with the Rules of the U.S. Patent and Trademark Office for recordation of this document.

Frommer Lawrence & Haug LLP, 745 Fifth Avenue, New York, NY 10151

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## ASSIGNMENT

0281031

Inventor: (Signature)	Date	Residence
Naofumi Nakamura Naofumi Nakamura	MAR. 12. 2004	Tokyo, Japan
)dideki Shiheta  Hideki Shibata	MAR. 1 2. 2004	Yokohama-shi, Japan
<u> </u>		
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RECORDING OFFICER:

After recording please return to: Frommer Lawrence & Haug LLP

745 Fifth Avenue New York, New York 10151